

WEST**Freeform Search****Database:**

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 US Pre-Grant Publication Full-Text Database
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 EPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

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 result set

DB=USPT; PLUR=YES; OP=OR

L10 L9 and substrate and silicon1250 L10L9 "(110)".clm.10952 L9L8 L7 and ((hydrogenated near4 nitride) or (oxynitride))94 L8L7 glass with ((passivation or base or underlayer or blocking) near4 (layer or film)) and (TFT\$1 or (thin adj film))2025 L7L6 fonash.in.18 L6L5 L4 not (semiconductor and energy and laboratory)105 L5L4 L3 and semiconductor365 L4L3 L2 and oxide1174 L3L2 L1 and (nickel with solution)1318 L2L1 amorphous same crystal\$840932 L1

END OF SEARCH HISTORY